



Docket No.: 214019US2

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## COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

RE: Application Serial No.: 09/955,076

Applicants: Eiji SAKAGAMI Filing Date: September 19, 2001

For: NONVOLATILE SEMICONDUCTOR MEMORY

AND METHOD OF FABRICATING THE SAME

Group Art Unit: 2814 Examiner: H. WEISS

SIR:

Attached hereto for filing are the following papers:

## REQUEST FOR RECONSIDERATION UNDER 37 C.F.R. § 1.111

Our check in the amount of is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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## IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

:

**EIJI SAKAGAMI** 

:EXAMINER: H. WEISS

SERIAL NO: 09/955,076

RCE FILED: APRIL 26, 2004

:GROUP ART UNIT: 2814

FOR: NONVOLATILE SEMICONDUCTOR

MEMORY HAVING MONOS STRUCTURE AND METHOD ...

## REQUEST FOR RECONSIDERATION UNDER 37 C.F.R. §1.111

COMMISSIONER FOR PATENTS ALEXANDRIA, VA 22313

SIR:

In response to the Office Action dated July 26, 2004, please reconsider the aboveidentified application:

Remarks/Arguments begin on page 2 of this paper.